



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: James D. Pylant et al.

Issue Date: July 12, 2005

Serial No.: 10/623,131

U.S. Patent No. 6,915,906 B2

Title: Wafer Storage Container with Wafer Positioning Posts

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Certificate
MAR 3 0 2006

of Correction

FEE TRANSMITTAL

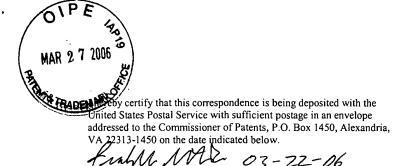
Sir:

Enclosed are 1) a Certificate of Correction Form (PTO/SB/44) and 2) a
Request for a Certificate of Correction to correct errors that were found in US
Patent 6,915,906. The Commissioner is authorized to charge \$100.00 to Deposit
Account 50-2991 to process the Certificate of Correction.

Respectfully submitted,

Isabelle R. McAndrews, Attorney for Applicants

Reg. No. 34,998



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Serial No.: 10/623,131

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Certificate of Correction Branch Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Request for Certificate of Correction Under 37 CFR 1.323

Applicants have discovered typographical errors in the issued claims of the above-identified patent. Specifically, Claims 1 and 8 omit language originally present in the claims. Claim 1 was amended in the response filed on 01-03-05 to include "a wafer storage chamber *having a specific height*". However the text of claim 1 was incorrectly copied, resulting in the omission of the italicized text in subsequent correspondence with the PTO. The language to be inserted in claim 8 was mistakenly omitted by the PTO, whereas Claim 13 has a minor grammatical error. All of these errors occurred in good faith and without deceptive intent. Applicants have set forth the corrections to be made in the attached Form PTO/SB/44. The Patent Office is authorized to charge the Fee for this request from Deposit Account 50-1991.

Respectfully submitted,

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Isabelle R. McAndrews Attorney for Applicants

Reg. No. 34,998

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

Page 1 of 1

PATENT NO.

: 6,915,906 B2

APPLICATION NO.: 10/623,131

ISSUE DATE

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INVENTOR(S)

: James D. Pylant et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

> Col. 5, line 8, replace the text "a wafer storage chamber for storing a stack of wafer elements," with --a wafer storage chamber having a specific height for storing a stack of wafer elements--.

Col. 6, line 2, replace the text, "adapted the stack" with --adapted to surround the stack--.

Col. 6, line 23, replace the term "assist" with --assists--.

MAILING ADDRESS OF SENDER (Please do not use customer number below):

Isabelle R. McAndrews 38507-G Cherry St. Newark, CA 94560

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Office, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.